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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/659,194	09/09/2003	Satoru Oishi	1232-5145	5596	
27123 75	90 09/07/2004		EXAM	EXAMINER	
MORGAN & FINNEGAN, L.L.P. 3 WORLD FINANCIAL CENTER			NGUYEN, HUNG		
	NY 10281-2101		ART UNIT PAPER NUMBER		
			2851	· · · · · · · · · · · · · · · · · · ·	
			DATE MAILED: 09/07/2004	4	

Please find below and/or attached an Office communication concerning this application or proceeding.

			74.3
	Application No.	Applicant(s)	
	10/659,194	OISHI, SATORU	
Office Action Summary	Examiner	Art Unit	
	Hung Henry V Nguyen	2851	
The MAILING DATE of this communication a Period for Reply	appears on the cover sheet with	the correspondence addres	SS
A SHORTENED STATUTORY PERIOD FOR REATHE MAILING DATE OF THIS COMMUNICATION  - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a lif NO period for reply is specified above, the maximum statutory perions for reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the material patent term adjustment. See 37 CFR 1.704(b).	N. 1.136(a). In no event, however, may a repreply within the statutory minimum of thirty fod will apply and will expire SIX (6) MONTI tute, cause the application to become ABA	oly be timely filed  (30) days will be considered timely.  HS from the mailing date of this commu  NDONED (35 U.S.C. § 133).	inication.
Status			
1) ☐ Responsive to communication(s) filed on 09 2a) ☐ This action is <b>FINAL</b> . 2b) ☐ T  3) ☐ Since this application is in condition for allow closed in accordance with the practice under	his action is non-final. wance except for formal matte	•	erits is
Disposition of Claims			
4) ☐ Claim(s) 1-17 is/are pending in the applicating 4a) Of the above claim(s) is/are with the state of the above claim(s) is/are allowed.  5) ☐ Claim(s) 1-17 is/are rejected.  7) ☐ Claim(s) is/are objected to.  8) ☐ Claim(s) are subject to restriction and state of the application	Irawn from consideration.		
Application Papers			
9)☐ The specification is objected to by the Exam 10)☒ The drawing(s) filed on <u>09 September 2003</u> Applicant may not request that any objection to t Replacement drawing sheet(s) including the corr 11)☐ The oath or declaration is objected to by the	is/are: a) $\boxtimes$ accepted or b) $\square$ he drawing(s) be held in abeyand rection is required if the drawing(s	e. See 37 CFR 1.85(a). ) is objected to. See 37 CFR 1	.121(d).
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the papplication from the International Bure * See the attached detailed Office action for a light service.	ents have been received. ents have been received in Ap riority documents have been re eau (PCT Rule 17.2(a)).	plication No eceived in this National Sta	ge
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/	08) 5) 🔲 Notice of Info	/Mail Date ormal Patent Application (PTO-152	2)
Paper No(s)/Mail Date	6)	<b>-</b> •	

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#### **DETAILED ACTION**

# Claim Rejections - 35 USC § 112

- 1. The following is a quotation of the second paragraph of 35 U.S.C. 112:
  - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 2. Claims 3-5 and 16 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

As to claims 3-5, the recitations of "the alignment mark <u>may</u> improve" or "acquiring step <u>may</u> reduce" or "acquiring step <u>may</u> approach a predetermined interval" render the claims indefinite since it has been held that the recitation of a device "may" perform a function is not a positive limitation and it does not constitute a limitation in any patentable sense.

Claim 16 recites the limitations "the value" and "the device" in line 6. There are insufficient antecedent basis for these limitations in the claim.

### Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

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(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

4. Claims 1-17 are rejected under 35 U.S.C. 102(e) as being anticipated by Okita et al (U.S.Pat. 6,538,721).

With respect to claim 16, Okita discloses an exposure apparatus for transferring a predetermined pattern form on a reticle (M) onto a substrate (W) and comprising all basic features of the instant claims such as: a surface position detecting means (51-58) for acquiring information of an alignment mark formed on the substrate (see figure 2) by changing a value of a device parameter, the obtained information being used for an alignment between the mask and the substrate (see col.6, lines 37 thru col.7 line 63) and an optimization part (27, 90) for setting the value of the device parameters to the exposure apparatus based on the information obtained (see col.7, lines 64 thru col.8 line 44). Okita further teaches the alignment mark formed on the substrate including plural elements arranged at a desired interval (see figure 2a-2c) and the device parameters including an arrangement of sample shot for an advance global alignment, illumination mode, exposure line width, mark width, mark line width and a width of a process window (see figures 4 and 5; see col.13, lines 35).

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As to claims 1-15, the corresponding method claims are seen inherent teachings in existence of the above apparatus.

With respect to claim 17, even though Okita does not expressly disclose a program for enabling a computer executing the exposure method as claimed but this feature is seen to be an inherent teaching of the exposure apparatus of Okita since a CPU (90) for performing the exposure apparatus is disclosed and it is apparent that some type of program must be present for the CPU to function as intended.

## Prior Art Made of Record

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Morimoto (U.S. 2003/0059691 A1); Kasuga (U.S.Pat. 5,656,402) and Ina et al (U.S.Pat. 6,639,677) discloses an exposure apparatus and method for automatically measuring shot compensation parameters and providing precision alignment between the reticle and the substrate in accordance with the shot compensation parameters.

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hung Henry V Nguyen whose telephone number is 571-272-2124. The examiner can normally be reached on Monday-Friday (First Friday off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on 571-272-2258. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hung Henry V Nguyen Primary Examiner

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hvn 89/2/04